



中國科學院為能物招加完所 Institute of High Energy Physics Chinese Academy of Sciences



Vector-like quark T' search and Status of CMS-HGCAL Module Assembly Center(Beijing)

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Vector-like quark T' search







Standard Model

Fermions: quarks, leptons

Mass: Yukawa coupling to the Higgs

Hierarchy problem

- VLQs: hypothetical new spin -1/2 charge 2/3 particle
- VLQs offer a potential solution to the hierarchy problem of standard model
- Using all the Run2 data to search for VLQs

little Higgs, composite Higgs models

Fermions: Vector-like quarks

non-Yukawa coupling terms

Don't excluded by precision SM measurements

CMS Integrated Luminosity, pp, $\sqrt{\mathbf{s}}=$ 13 TeV





VLQs production and decay modes





- The vector-like quarks mainly coupled to the third generation
- Three different decay channels into SM particles by the assumption of the model: bW, tH, tZ

arXiv:0907.3155









ATLAS@Run1: mass excluded region: below 650-950GeV @95%CL.





Vector-Like quarks T' @2015 and 2016





ATLAS@2016 mass excluded region : below 1300GeV以下@95%CL











- Final state: MET + Jets
- CMS first use this final state to search T'





Analysis strategy



Forward jets: define two categories with enhanced sensitivity

- ✓No forward jets
- ✓At least 1 forward jet
- The top quark identified in three different scenarios:



- Neutrinos are not detected in the experimental apparatus.
- T quark four-momentum cannot be reconstruction

AK4 jet: anti-kt jet with radius = 0.4

AK8 jet: anti-kt jet with radius = 0.8

So We have six categories in each year





Events reconstruction and Selection



In order to improve the sensitivity of the analysis, the following selection is applied:





Background Estimation



- Main Background: Z+jets, W+jets, ttbar
- Using Data-driven method to get correction factors from control region in data
- Control regions for the main backgrounds are defined as:

➢ Resolved category

Variable	SR	Z+jets CR	W+jets CR	ttbar CR
lepton	veto	veto	>=1	>=1
Number of midum b jet	>=1	=0	=0	>=1

Partially merged category

Variable	SR	ttbar CR
minΦ(MET,jet)	> 0.6	< 0.6

Fully merged category

Variable	SR	W/Z+jets CR	ttbar CR
Leotpn	veto	veto	1 loose muon or electron
minΦ(MET,jet)	> 0.6	> 0.6	No cut
Top jet	1 b-subjet	0 b-subjet	1 b-subjet





Systematics



Source	Effect(%)	Туре
Luminosity	1.8	rate
Pileup	0.2-3	rate
b-tagging	0.5-1.2	rate
Top tagging	9-10	rate, shape
W tagging	7-8	rate, shape
Trigger efficiency	1-3	rate, shape
Prefiring	0.2-3	rate, shape
JES	2-18	rate, shape
JER	2-5	rate, shape
PDF	1-5	rate
μ_F 和 μ_R	8-13	rate, shape
Background scale factors	5-30	rate, shape

The dominant systematics are: top tagging, W tagging, μ_R , μ_F , background SF





95% confidence level(CL) exclusion limits on the production cross section of T' times BR



- Narrow width resonance: cross section : greater than 602–15 fb. Masses: below 0.98TeV
- 10-30% width resonance : cross section : greater than 836–16 fb Masses: below 1.4TeV
- 2D limit: The hashed red line indicates the boundary of the excluded region





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Status of CMS-HGCAL Module Assembly Center(Beijing)



CMS-HGCAL project: motivations





≻CMS endcap calorimeters: Phase-2 upgrade

- Harsh environment at HL-LHC: high pile-up, high radiation level
- Required to replace the existing endcap calorimeters
- Construct a High Granularity Calorimeter: HGCAL project



CMS HGCAL project overview



2 m Mass ~200 T (each endcap) Ε 2.62 N= 1.5 CE-E Ш (Si) 22 n = 3 R1 = 0.28 m Beam Pipe

 \succ Key Parameter(update from the TDR):

- HGCAL covers 1.5<|n|<3.0
- Full system maintained at -30°C
- ~640 m² of silicon sensors
- ~370 m² of scintillators
- 6.1M silicon channels: 0.5 or 1.1cm2 cell size
- 240k scintillator-tile-SiPM channels
- Data readout from all layers
- ~31k Si-modules: including spares
- > Active layers and elements
 - Si-sensors (full and partial hexagons) in CE-E and high-radiation region of CE-H
 - SiPM-on-Tile in low-radiation region of CE-H

\succ Electromagnetic calorimeter(CE-E):

- 28 layers, $25.5X_0(1.7\lambda)$
- Si, Cu/CuW/Pb absorbers
- ➤ Hadronic calorimeter(CE-H):
 - 22 layers, ~9.5 λ(including CE-E)
 - Si & scintillator, steel absorbers



Structure of CMS endcap calorimeter







Module Assembly Center(MAC)



- ➤HGCAL: ~31000 silicon modules
 - Module assembly chain established
- Module Assembly Center(MAC)
 - 6 MACs world wide: 3 in Asia, 3 in US
 - Each MAC expected to assembly ~5000 silicon module
 - MAC-Beijing: a dedicated silicon lab on IHEP campus

►MAC at IHEP

 140m² Clean room: temperature 21±1°C, humidity: 45±10%, Monitoring of particle level: better than Class 1000









npearture & Humidity (0621-062)



Semi-finished module

(chai)

OGP

Good Modul

chair Gule

Curing cabine

Encapsulation

estin

table

Module Assembly

chain

Glue

Curing cabin

Gantry

PC

(chai)

Wire-bonding

Micro

chair & Scope

Wirchon chair

der

Base plate & Kapton

mperati

cycling

sysem

To be

tested

Component Test

Senso

tester

PCB

Test

system.

Gowning area

saving

data

Test

system

Component

(chair)

Problem Module

chair

Module Tests

Granite ta



Key procedure in module assembly: component Testing



Component testing

Module Assembly by Gentry



Encap

Module Encapsulation



➢PCB testing: Optical gauging product(OGP)

- Extensive measurements performed for baseplates, PCBs: size, boundaries, thickness, flatness
- Visual inspection boosted by machine learning: identify and categorize scratches on silicon sensors
- Thickness tolerance of sensor on PCB < 40µm
- Thickness tolerance of module < 125µm
- Standard tolerance: 250µm
- Flatness meeting the requirement

Hex-sensor

- Delta_x ~ 24 µm
- Delta_y ~ 45 μm
- Center-to-center tolerance: 50µm





ASSEN			
5		X(mm)	Y(mm)
17	Baseplate	40.34447	104.39552
riginal image		40.35422	104.41038
A	Sensor	40.35995	104.36856
A		40.36047	104.37022
int.	Hexaboard	40.33810	104.41023
-12		40.33637	104.41361



>Module assembly: with the main gantry and tooling (camera, gantry head, fixtures, etc.)

- Precision pick-and-place movements with components, fine glue dispensing
- Automated operations with dedicated software





Key procedure in module assembly: Wiring bonding





- Wire-bonding: to build electrical connections between silicon sensors and PCB
 - Exercises with dummy sensors and PCBs and optimize bonding parameters
 - Applied optimized parameters for the assembly 8-inch real modules





Schematics of wire-bondings of silicon modules (side view) Stepped holes Wire bonds Guard Silicon (320 µm) KaptonTM foil plated with gold (- 100 µm) 1.2 mm Baseplate

- Wire-bonding quality (by pull tester): wire-bonds can fulfill the strength requirement
 - Destructive pull test: measure the strength of bonding wires and feet
 - Non-destructive test: to extract the correction factor to be applied for destructive pull tests
 - Wire-bond in a triangle form (max. 5gf strength set)





Key procedure in module assembly: Encapsulation





- Mini-gantry system: dispense glue to encapsulate the wirebonds for better mechanical stability
 - Mini-gantry: to dispense glue points into the stepped holes of PCBs, exercises with mock-ups
 - Centrifuge: to remove bubbles in 2-component glue mixture









Hex-aboard Electronics testing











chip 0

normal channels

calibration channels





- Low noise for hex-aboard
- Good pedestal for hex-aboard

DAQ system diagram



Si-Module Electronics testing





Module Electronics testing





Noise before/after assembly



Pedestal before/after assembly



- Low noise before/after assembly
- Good pedestal before/after assembly
- Good IV for the Module



Module assembly at IHEP(1)



Successfully assembled the first 8-inch silicon module: the first MAC to achieve this goal

- Applied optimized parameters from extensive exercises of dummy module assembly
- Full functionality demonstrated in lab tests →validated the 8" silicon module design



- ➢Beam testing at CERN SPS in Sep.-Oct. 2021
 - Two silicon modules(HGCROC v2, v3) assembled by IHEP was tested in CERN
 - Successfully seen hexa-board response to beam: MIP signals











Module assembly at IHEP(2)



 Successful assembly of the second 8-inch LD module



- A successed small "mass" pre-production
 - 5 modules ship box
 - · Module mounted on carrier board
 - Carrier board regulated by rubber





MAC Beijing Certify



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December 15, 202

Subject: Certification of qualification the HGCAL Module Assembly Centre a IHEP, Beijing

To whom it may concern,

I am writing as Project Manager for the CMS endcap calorimeter upgrade project (HGCAL) to certify that the silicon module assembly center (MAC) at IHEP Beijing, led by Prof. Huaqiao Zhang, has been qualified for the HGCAL project as ready to move into the Pre-Series phase of construction.

HGCAL will replace several of the present CMS sub-detectors: the silicon/lead endcap pre-shower detector, the lead-tungstate crystal electromagnetic endcap calorimeter, and he plastic/brase endcap hadron calorimeter. HCCAL is a novel sampling calorimeter, based on a large-scale deployment of silicon modules (a grand total of approximately modules will be complemented with plastic similation time instruments). By silicon photomultipliers (SiPMs) in regions of the detector where particles arrive with lower intensity.

The qualification of the IHEP Beijing MAC has been completed on time to meet the corresponding project milestone. The MAC is set up in a Class 1000 clean room that is dedicated to this facility and all of the equipment for mass production of silicon modules for HGCAL has been installed in the clean room and commissioned. This equipment includes a gatry machine for automated module assembly, a wire-bonding machine, an optical inspection and coordination measurement machine, and a silicon module stand. The IHEP Beijing team has been trained in how to use the MAC equipment, and they have practiced extensively on dummy module components before moving onto using live components.

which will be used for the integration of larger prototype assemblies ('cassettes') of the HCCAL detector. The pre-series phase will exercise all the handling, the tociling, and the QA/CC procedures associated with large scale module assembly and testing. It will also permit a deep study and characterization of the robustness of the pre-series modules with large statistics.

We plan to start the pre-series assembly in 2022, once the component parts are all available, and beyond the pre-series, we look forward to ramping up the IHEP Beijing MAC for full-scale mass production.

Yours faithfully,

k. lin

Karl A. Gill CMS HGCAL Project Manager





Summary



➢ Vector-Like quark T' search

- Study of single production of VLQ in tZ (top hadronic, Z to neutrinos) has been shown all Run2 data
- This is first result of MET + jets final state in CMS
- This is the current best published result on single-VLQ T' in the tZ(vv) decay channel.

	Cross section@95%CL	Mass@95%CL
Narrow width resonance	>602-15fb	<0.98TeV(5%)
10-30% width resonance	>836–16 fb	<1.4TeV(30%)

Status of CMS-HGCAL Module Assembly Center(Beijing)

- Infrastructure established: 140m² clean room, key equipment, test stands, services
- Have the ability to do full chain Module assembly
- MAC-Beijing qualified : Successfully built the first 8-inch silicon module and have built 7 modules, full functionality demonstrated in lab tests
- Complete the MAC certificate





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Back up











signal selection efficiency



• The signal selection efficiency for different categories list here:











Background estimation test





Comparison of data and the predicted background(resolved)



Background estimation test







Results-Resolved topology





· All background processes are derived from the fit to data



Results – Partially merged topology







Results – Fully merged topology











LHC上的硬散射过程的截面可以写成: $\sigma_{h_1h_2} \rightarrow x = \sum_{a,b} \int_0^1 dx_1 dx_2 f_{h_1/a}(x_1,\mu_F^2) f_{h_2/b}(x_2,\mu_F^2) \cdot \hat{\sigma}_{a,b \rightarrow x}(x_1,x_2,\alpha_s(\mu_R^2),\frac{Q^2}{\mu_F^2},\frac{Q^2}{\mu_R^2})$

▶部分子分布函数误差

其中 $f_{h_1/a}(x_1,\mu_F^2)f_{h_2/b}(x_2,\mu_F^2)$ 是部分子分布函数(PDF),从实验中测量得到其误差 →本底信号产额或横质量形状

▶因子化参数和重整化参数误差

可以看到式子中因子化参数和重整化参数 μ_F 和 μ_R 会影响硬散射过程的截面,通过把 μ_F 和 μ_R 的值加倍或者减半来估计其造成的误差

→本底信号产额或横质量形状



产生截面限制的计算方法





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SiPM-on-Tile Module



"SiPM-on-Tile" Modules





"<u>SiPM-on-Tile</u>" design: scintillator tile directly coupled with SMD-SiPM



